

PATENT
Attorney Docket No.: SAM-0298

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jae-Hak Kim, *et al.*

Serial No.: 09/994,508

Filing Date: November 27, 2001

Title: METHOD OF FABRICATING SEMICONDUCTOR DEVICES HAVING LOW
DIELECTRIC INTERLAYER INSULATION LAYER

Examiner: Steven H. Rao

Group Art Unit: 2814

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this paper and any attachments hereto are being forwarded to the United States Patent and Trademark Office via facsimile at the facsimile telephone number and on the date indicated below.

3/11/05

Date

(571) 273-1718

Facsimile Number



Chelsey Davis

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

SUPPLEMENTAL AMENDMENT

Sir:

The following amendment is submitted in accordance with the telephone interviews conducted with the undersigned on March 3, 2005 and March 10, 2005. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.

PATENT
Attorney Docket No.: SAM-0298
Customer No.: 29344

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TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

1. Supplemental Amendment

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: 3/11/05
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E-MAIL: MAIL@MILLSONELLO.COM**FACSIMILE TRANSMISSION**

TO: United States Patent and Trademark Office **FROM:** Steven M. Mills
Examiner Steven H. Rao
Group Art Unit: 2814

FAX NO: (571) 273-1718 **DATE:** March 11, 2005

RE: U.S. Patent Application
"Method of Fabricating Semiconductor Devices Having Low Dielectric
Interlayer Insulation Layer," by Jae-Hak Kim, *et al.*
U.S. Serial No.: 09/994,508
U.S. Filing Date: November 27, 2001
Attorney Docket Number: SAM-0298

NUMBER OF PAGES INCLUDING COVER SHEET: 10**REMARKS:**

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